

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	1029	378/34	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 10:57	
2	BRS	L7	13	1 and (displacement adj sensor)	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 14:36	
3	BRS	L13	5718	substrate and stepper	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 11:15	
4	BRS	L19	1	13 and (vibration adj insulation)	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 11:13	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
5	BRS	L25	784	13 and x-ray	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 11:17	
6	BRS	L31	89	13 and (x-ray adj source)	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 11:17	
7	BRS	L37	7	7 and stepper	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:00	
8	BRS	L43	6	37 and substrate	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 11:59	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
9	BRS	L49	0	7 and (stepper same (helium adj beam))	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:01	
10	BRS	L55	0	(x-ray adj source) and (stepper same (helium adj beam))	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:01	
11	BRS	L61	0	(stepper same (helium adj beam))	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:02	
12	BRS	L67	21	(helium adj beam)	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:05	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
13	BRS	L73	0	(helium adj beam adj transport adj chamber)	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:05	
14	BRS	L79	3	(beam adj transport adj chamber)	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:05	
15	BRS	L85	0	7 and dvrt	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:22	
16	BRS	L91	0	x-ray and dvrt	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:22	

	Typ	L #	Hits	Search Text	DBs	Time Stamp	Comments
17	BRS	L97	8	differential adj variable adj reluctance adj transducer	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:36	
18	BRS	L10 3	0	7 and 100nm	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 12:26	
19	BRS	L10 9	46	100nm and x-ray	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 14:30	
20	BRS	L11 5	0	97 and (displasment adj sensor)	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/06 13:44	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
21	BRS	L12 1	1161 6	micron and x-ray	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/0 6 14:30	
22	BRS	L12 7	1132	0.1 adj micron and x-ray	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/0 6 14:32	
23	BRS	L13 3	1408	121 and lithography	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/0 6 14:34	
24	BRS	L13 9	174	1 and 133	USP AT; EPO; JPO; DER WEN T; IBM TDB	2001/08/0 6 14:36	